



Serial No.: 09/000,824
Attorney Docket No. 41980.002004

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re US Patent Application of:)	
)	
Jayantha AMARASEKERA et al.)	
)	
Serial No.: 09/000,824)	Group Art Unit: 1713
)	
Filing Date: December 30, 1997)	Examiner: C. Lu Rutt
)	
Title: SILICONE COMPOSITIONS FOR)	
HIGH VOLTAGE INSULATOR)	
APPLICATIONS)	

**PETITION FOR REVIVAL OF AN APPLICATION FOR PATENT
ABANDONED UNINTENTIONALLY UNDER 37 C.F.R. §1.137(b)**

Attention: Office of Petitions
Assistant Commissioner for Patents
Box DAC
Washington, D.C. 20231

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AUG 09 2001

Sir:

OFFICE OF PETITIONS
DEPUTY A/C PATENTS

The above-identified application became abandoned for failure to file a timely and proper reply to the Official Action, dated August 11, 2000, by the United States Patent and Trademark Office. The date of abandonment is the day after the expiration date of the period set for reply in the Office notice or action plus an extension of time actually obtained.

Applicant respectfully petitions for revival of the above-identified patent application. In order to obtain a grantable petition, the applicant is submitting the required items which are listed below.

- 1) Petition Fee in the amount of \$1,240.00 as set forth under 37 C.F.R. §1.17(m);
- 2) A Reply

A) The Reply to the above-noted Official Action in the form of
an Amendment is enclosed herewith.

3) A Terminal Disclaimer is not necessary due to the fact that the above-identified patent application was filed after June 8, 1995; and

4) STATEMENT: The entire delay in filing the required reply from the due date for the required reply until the filing of a grantable petition under 37 C.F.R. §1.137(b) was unintentional.

Respectfully submitted,

HUNTON & WILLIAMS

Date: August 7, 2001

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